

Title (en)
SUBSTRATE HOLDER AND METHOD FOR BONDING TWO SUBSTRATES

Title (de)
SUBSTRATHALTER UND VERFAHREN ZUM BONDEN ZWEIER SUBSTRATE

Title (fr)
DISPOSITIF ET PROCÉDÉ POUR RELIER DEUX SUBSTRATS

Publication
EP 3281220 A1 20180214 (DE)

Application
EP 15717136 A 20150410

Priority
EP 2015057859 W 20150410

Abstract (en)
[origin: WO2016162088A1] The invention relates to a substrate holder (1, 1', 1", 1"', 1IV), comprising a fixing surface (4o) for holding a substrate (11, 11').

IPC 8 full level
H01L 21/67 (2006.01)

CPC (source: EP KR US)
H01L 21/187 (2013.01 - KR); **H01L 21/67092** (2013.01 - EP KR US); **H01L 21/67109** (2013.01 - EP KR US); **H01L 21/67346** (2013.01 - US); **H01L 21/68** (2013.01 - US); **H01L 24/80** (2013.01 - US)

Citation (examination)
JP 2005302858 A 20051027 - NIKON CORP

Designated contracting state (EPC)
AL AT BE BG CH CY CZ DE DK EE ES FI FR GB GR HR HU IE IS IT LI LT LU LV MC MK MT NL NO PL PT RO RS SE SI SK SM TR

Designated extension state (EPC)
BA ME

DOCDB simple family (publication)
WO 2016162088 A1 20161013; CN 107533996 A 20180102; CN 107533996 B 20210223; EP 3281220 A1 20180214; JP 2018515908 A 20180614; KR 102298898 B1 20210907; KR 20170137050 A 20171212; KR 20200059324 A 20200528; SG 11201706844Q A 20171030; TW 201642386 A 20161201; TW 201923962 A 20190616; TW I647786 B 20190111; TW I683393 B 20200121; US 11315813 B2 20220426; US 2018040495 A1 20180208

DOCDB simple family (application)
EP 2015057859 W 20150410; CN 201580077827 A 20150410; EP 15717136 A 20150410; JP 2017547970 A 20150410; KR 20177024926 A 20150410; KR 20207014509 A 20150410; SG 11201706844Q A 20150410; TW 105109074 A 20160323; TW 107141955 A 20160323; US 201515551733 A 20150410